

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/838,553	CHOI ET AL.	
Examiner	Art Unit	
Duc T. Duona	2663	

	SEARCHED					
Class	Subclass	Date	Examiner			
updated	\	6/27/05	00			
370	331,332					
455	436 ₁ 437	→	V			

INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			
310	331,332	6/27/05	DD			
455	436,437	J	V			
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
see Ricky Ngo East text	6/24/05	90		
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